



112d

Receipt

**PATENT APPLICATION**

**THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q72770

Takashi SATO, et al.

Appln. No.: 10/532,966

Group Art Unit: 1751

Confirmation No.: 9033

Examiner: Not yet assigned.

Filed: April 27, 2005

For: **COMPOSITION FOR POLISHING METAL, POLISHING METHOD FOR METAL LAYER AND  
PRODUCTION METHOD FOR WAFER**

**REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT**

**ATTN:** Office of Initial Patent Examination

Filing Receipt Correction

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

We enclose a copy of the Official Filing Receipt for the above-identified application and request the following correction:

**Title:** Composition for polishing metal, polishing metod for metal layer, and production method for wafer; Composition for polishing metal, polishing method for metal layer, and production method for wafer

Verification for the requested correction is indicated on the Declaration filed April 27, 2005.

Respectfully submitted,

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WASHINGTON OFFICE  
23373  
CUSTOMER NUMBER

Date: May 2, 2006



UNITED STATES PATENT AND TRADEMARK OFFICE

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/532,966	04/27/2005	3110		Q72770		21	1

CONFIRMATION NO. 9033

CORRECTED FILING RECEIPT



\*OC000000018374580\*

23373  
SUGHRUE MION, PLLC  
2100 PENNSYLVANIA AVENUE, N.W.  
SUITE 800  
WASHINGTON, DC 20037

Date Mailed: 03/24/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

**Applicant(s)**

- ✓ Takashi Sato, Shiojiri-shi, JAPAN;
- ✓ Ayako Nishioka, Chiba-shi, JAPAN;
- ✓ Nobuo Uotani, Shiojiri-shi, JAPAN;

**Assignment For Published Patent Application**

- ✓ Showa Denko K.K.

**Power of Attorney:** The patent practitioners associated with Customer Number 23373.

**Domestic Priority data as claimed by applicant**

This application is a 371 of PCT/JP03/14026 10/31/2003 ✓  
which claims benefit of 60/426,399 11/15/2002 ✓

**Foreign Applications**

JAPAN 2002-317705 10/31/2002 ✓

**If Required, Foreign Filing License Granted:** 03/24/2006

**The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/532,966****

**Projected Publication Date:** Not Applicable

Non-Publication Request: No

Early Publication Request: No

Title

Composition for polishing metal, polishing method for metal layer, and production method for wafer

Preliminary Class

252 Composition for polishing metal, polishing method for metal

layer, and production method for wafer.

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